



2851

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Akihiro NAKAUCHI et al.

Application No.: 09/845,297

Filed: May 1, 2001

For: PROJECTION EXPOSURE APPARATUS  
HAVING ABERRATION MEASUREMENT  
DEVICE

)  
:  
) Examiner: A. Mathews  
)  
:  
) Group Art Unit: 2851  
)  
:  
)  
:  
) April 22, 2003  
:  
)

Commissioner for Patents  
Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

☒ No additional fee is required.


The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	55	MINUS	55	= 0	x \$9 \$18	\$0.00
INDEP. CLAIMS	20	MINUS	20	= 0	x \$42 \$84	\$0.00
Fee for Multiple Dependent claims \$140/\$280						\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$0.00

☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.

- ☐ A check in the amount of \$\_\_\_\_\_ is enclosed.
- ☐ Charge \$\_\_\_\_\_ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
- ☐ A check in the amount of \$\_\_\_\_\_ to cover the fee for a \_\_\_\_\_ month extension is enclosed.
- ☐ A check in the amount of \$\_\_\_\_\_ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicants  
Steven E. Warner  
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200  
SEW/eab

DC\_MAIN 130387 v 1



00862.022217

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Akihiro NAKAUCHI et al.

Application No.: 09/845,297

Filed: May 1, 2001

For: PROJECTION EXPOSURE APPARATUS  
HAVING ABERRATION MEASUREMENT  
DEVICE

)  
:  
Examiner: A. Mathews  
)  
:  
Group Art Unit: 2851  
)  
:  
)  
:  
April 22, 2003  
)  
:  
)

The Commissioner for Patents  
Washington, D.C. 20231

#9/1  
4-28-03  
JPT  
(Entered  
in part)  
RECEIVED  
APR 24 2003  
TECHNOLOGY CENTER 2800

AMENDMENT

Sir:

In response to the Official Action dated January 22, 2003, please amend the above-identified application as follows:

INTRODUCTORY COMMENTS

This Amendment has been prepared in accordance with the Revised Format established by the U.S. Patent and Trademark Office, as permitted in the Pre-OG Notice dated February 4, 2003, and entitled "Amendments in a Revised Format Now Permitted."